

IDS - 05/27/2005



1711 Image

Attorney Docket No. 018765-171 Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Masafumi MIYAKAWA et al.

Application No.: 10/507,245 ✓

Filing Date: September 10, 2004

Group Art Unit:

Examiner:

Confirmation No.: 9077

Title: PRESSURE-SENSITIVE ADHESIVE FILM FOR THE SURFACE PROTECTION OF
SEMICONDUCTOR WAFERS AND METHOD FOR PROTECTION OF SEMICONDUCTOR WAFERS
WITH THE FILM

**SECOND
INFORMATION DISCLOSURE STATEMENT
TRANSMITTAL LETTER**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed is a SECOND Information Disclosure Statement and accompanying form
PTO-1449 for the above-identified patent application.

- ☒ No additional fee for submission of an IDS is required.
- ☐ The fee of \$180.00 (1806) as set forth in 37 C.F.R. § 1.17(p) is also enclosed.
- ☐ A statement under 37 C.F.R. § 1.97(e) is also enclosed.
- ☐ A statement under 37 C.F.R. § 1.97(e), and the fee of \$180.00 (1806) as set forth in 37 C.F.R. § 1.17(p) are also enclosed.
- ☐ Charge _____ to Deposit Account No. 02-4800 for the fee due.
- ☐ A check in the amount of _____ is enclosed for the fee due.
- ☐ Charge _____ to credit card. Form PTO-2038 is attached.

The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

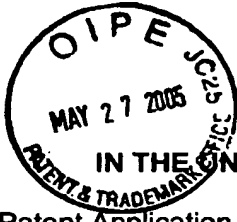
Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

P.O. Box 1404
Alexandria, Virginia 22313-1404
(703) 836-6620

By Robert G. Mukai
Robert G. Mukai
Registration No. 28,531

Date: May 27, 2005



Attorney's Docket No. 018765-171

In re Patent Application of)
Masafumi MIYAKAWA et al.) Group Art Unit:
Application No.: 10/507,245) Examiner:
Filed: September 10, 2004) Confirmation No.: 9077
For: PRESSURE-SENSITIVE ADHESIVE FILM FOR)
THE SURFACE PROTECTION OF)
SEMICONDUCTOR WAFERS AND METHOD)
FOR PROTECTION OF SEMICONDUCTOR)
WAFERS WITH THE FILM)

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, the accompanying information is being submitted in accordance with 37 C.F.R. §§ 1.97 and 1.98.

The listed documents were either cited in the specification, a Search Report dated January 21, 2005, from the corresponding Australian application, or the International Search Report in the corresponding PCT application.

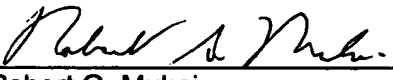
To assist the Examiner, the documents are listed on the attached form PTO-1449. Copies of the documents cited in the specification and the Australian Search Report are provided herewith along with translations thereof. However, only translations of the documents cited in the International Search Report are submitted as it is understood that the actual citations have already been transmitted by the International Bureau. In this last respect, the cited documents were previously identified in the First Information Disclosure Statement filed with the present application. However, on reviewing the citation form, it was

noted that the number and publication date for JP 2001-199932 is incorrect and a new citation sheet with the correct date for this published application is accordingly being provided herewith.

It is respectfully requested that an Examiner initialed copy of both citation forms be returned to the undersigned.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

By: 
Robert G. Mukai
Registration No. 28,531

P.O. Box 1404
Alexandria, Virginia 22313-1404
(703) 836-6620

Date: May 27, 2005

SECOND INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet

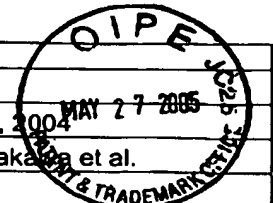
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of

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Complete if Known

Application Number 10/507,245
 Filing Date September 10, 2004
 First Named Inventor Masafumi Miyake et al.
 Examiner Name
 Attorney Docket Number 018765-171

**U.S. PATENT DOCUMENTS**

Examiner Initials	Document Number	Kind Code (if known)	Name of Patentee or Applicant of Cited Document	Issue/Publication Date (MM-DD-YYYY)
JM	6,187,874	B1	Yoshioka et al.	02-13-2001

FOREIGN PATENT DOCUMENTS

Examiner Initials	Document Number	Kind Code (if known)	Country	Date of Publication (MM-DD-YYYY)	STATUS						
					Translation	Partial Translation	Eng. Lang. Summary	Search Report	IPER	Abstract	Cited in Spec
JM	60-189938*	A	JP	09-27-1985	X					X	X
JM	5-335288*	A	JP	12-17-1993	X					X	X
JM	5-335411*	A	JP	12-17-1993	X					X	X
JM	6-77192*	A	JP	03-18-1994	X					X	
JM	6-77193*	A	JP	03-18-1994	X					X	
JM	6-73347*	A	JP	03-15-1994	X					X	
JM	2001-200215*	A	JP	07-24-2001	X			X		X	
JM	2 312 429*	A	GB	10-29-1997				X			
JM	0 539 973 A2*	A	EP	05-05-1993				X			
JM	10-1899504*	A	JP	07-21-1998	X			X		X	
JM	11-315259*	A	JP	11-16-1999	X			X		X	
JM	2000-8010*	A	JP	01-11-2000	X			X		X	

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
JM	English translation of JP 9-255933 published 09/30/1997*
JM	English translation of JP 2001-199932 published 07/24/2001*
JM	English translation of JP 2001-72951 published 03/21/2001*

*Copy attached.

Examiner Signature	/Jeffrey Mullis/ (05/10/2006)	Date Considered	05/10/2006
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

IDS - 03/20/2006

Attorney's Docket No. 1003510-000164

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Masafumi MIYAKAWA et al.

Application No.: 10/507,245

Filed: September 10, 2004

For: PRESSURE-SENSITIVE ADHESIVE FILM FOR
THE SURFACE PROTECTION OF
SEMICONDUCTOR WAFERS AND METHOD
FOR PROTECTION OF SEMICONDUCTOR
WAFERS WITH THE FILM



)
)
) Group Art Unit: 1711
)
) Examiner: JEFFREY C MULLIS
)
) Confirmation No.: 9077
)

**CORRECTION OF INFORMATION CONTAINED IN
SECOND INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In the Second Information Disclosure Statement filed in this application on May 27, 2005, it was stated that the number and publication date of a Japanese document (JP 2001-199932) cited in the First Information Disclosure Statement was incorrect, and a corrected Form PTO-1449 was submitted.

We have now learned that the original Form PTO-1449 submitted with the First Information Disclosure Statement filed on September 10, 2004 contained the correct information (i.e., JP 2001-19932 published 01-23-2001) (which can be verified by a review of the International Search Report for the corresponding PCT application).

It is accordingly requested that the corrected PTO Form-1449 filed in this application on May 27, 2005 **not be considered**. A further copy of PTO Form-1449 filed with the First Information Disclosure Statement on September 10, 2004 is enclosed herewith. It is respectfully requested that an Examiner initialed copy of the original citation form attached hereto be returned to the undersigned.

Respectfully submitted,

BUCHANAN INGERSOLL PC

By:

A handwritten signature in dark ink, appearing to read "Robert G. Mukai".

Robert G. Mukai
Registration No. 28,531

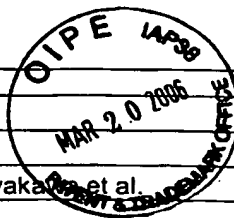
P.O. Box 1404
Alexandria, Virginia 22313-1404
(703) 836-6620
Date: March 20, 2006

FIRST INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Complete if Known

Sheet	1	of	1	Application Number	
				Filing Date	
				First Named Inventor	Masafumi Miyakawa et al.
				Examiner Name	
				Attorney Docket Number	018765-171



U.S. PATENT DOCUMENTS

Examiner Initials	Document Number	Kind Code (if known)	Name of Patentee or Applicant of Cited Document	Issue/Publication Date (MM-DD-YYYY)

FOREIGN PATENT DOCUMENTS

Examiner Initials	Document Number	Kind Code (if known)	Country	Date of Publication (MM-DD-YYYY)	STATUS						
					Translation	Partial Translation	Eng. Lang. Summary	Search Report	IPER	Abstract	Cited in Spec
JM	9-255933	A	JP	09-30-1997				X			
JM	2001-19932*	A	JP	01-23-2001				X		X*	
JM	2001-72951	A	JP	03-21-2001				X			

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

*Copy attached.

Examiner Signature	/Jeffrey Mullis/ (05/10/2006)	Date Considered	05/10/2006
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.